

Docket No.: 21064/0206584-US0  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Koichi Wago

Application No.: 10/665,275

Confirmation No.: 5466

Filed: September 22, 2003

Art Unit: 1756

For: ROTARY APERTURED INTERFEROMETRIC  
LITHOGRAPHY (RAIL)

Examiner: M. J. Angebranndt

**AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

OK to  
Ent  
no  
8/29/07  
In response to the Office Action dated May 24, 2007, finally rejecting claims 1-3, 6, and 8-19, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.